

03

B



Docket No. 740756-2296

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Hisashi OHTANI et al. ) Group Art Unit: 2815  
Serial No. 09/837,552 ) Examiner: N. Drew Richards  
Filed: April 19, 2001 ) Confirmation No. 7555  
For: SEMICONDUCTOR DEVICE AND ) Date: November 5, 2003  
MANUFACTURING METHOD  
THEREOF

**REQUEST FOR ACKNOWLEDGEMENT OF  
INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

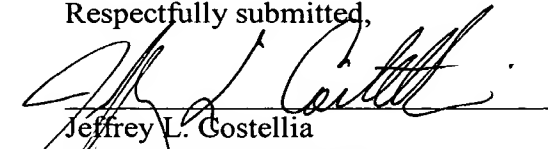
Sir:

Information Disclosure Statements with Forms PTO-1449 was filed in the above-identified patent application on July 14, 2003. Applicants have not yet received back from the Examiner a copy of the Forms PTO-1449 initialed to acknowledge the fact that the Examiner has considered the cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Forms PTO-1449.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,

  
Jeffrey L. Costellia  
Registration No. 35,483

NIXON PEABODY LLP  
Suite 900  
401 9<sup>th</sup> Street, N.W.  
Washington, D.C. 20004-2128  
(202) 585-8000  
NVA281236.1